

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT: Masaki Shioya **GROUP:** 2121
SERIAL NO: 10/822,266 **EXAMINER:** R. Hartman, Jr.
FILED: April 8, 2004 **CONFIRMATION:** 2711
FOR: FACILITY CONTROL MONITOR METHOD AND
FACILITY CONTROL MONITOR APPARATUS

Commissioner for Patents
PO Box 1450
Alexandria, Virginia 22313-1450

RESPONSE UNDER 37 C.F.R. 1.116

In response to the Office Action mailed February 21, 2007, the following amendments and remarks are respectfully submitted in connection with the above-identified application.

OK for Entry
x ROH
5/28/2007